Achieving Adjustable Digital-to-Analog Conversion in Memristors with Embedded Cs₂AgSbBr₆ Nanoparticles

Supplementary Material

Yuchan Wang ^{a,‡,*}, Nannan Xu ^{a,‡}, Yiming Yuan ^a, Wenxia Zhang^{a,*}, Qiang Huang ^a,

Xiaosheng Tang ^a and Fei Qi ^{a,*}

^a.Optoelectronic Engineering, Chongqing University of Posts and Telecommunications, Chongqing 400065, China, yuchanwang87@163.com, zhangwx@cqupt.edu.cn, qifei@cqupt.edu.cn

[‡]. These authors contributed equally to this paper.

KEYWORDS: lead-free double perovskites, nanoparticles, resistive switching memories, memristors, conductive filaments



Fig. S1 (a) The absorption spectra of Cs₂AgSbBr₆-NPs powders, the inset shows the optical image of the powders. (b) The transmission spectra of PMMA&Cs₂AgSbBr₆-NPs film, the inset shows the optical image of the transparent Cs₂AgSbBr₆-NPs memristor device.



Fig. S2 The retention ability of Ag/PMMA&Cs₂AgSbBr₆-NPs (5%)/ITO devices, the reading voltage is 0.1 V.



Fig. S3 (a) Schematic diagram of the artificial synaptic behavior measurement circuit. (b) The actual diagram of the test setup, the inset exhibits the waveform plot of artificial synapse measured from the oscilloscope.



Fig. S4 (a) The dependence of the resistance states on the area of top Ag electrodes. (b) The I-V curve of the Au/PMMA&Cs₂AgSbBr₆-NPs/ITO memristor device. The fitting lines of typical I-V curve with log-log scale during (c) the positive bias-voltage and (d) the negative bias-voltage.



Fig. S5 The 2D axisymmetric model of the memristor in the simulation software. The Cs₂AgSbBr₆-NPs are spheres with a diameter of 3 nm which are homogeneously added in the PMMA layer.



Fig. S6 Schematic diagram of the formation and rupture of Ag-conducting filaments.

| Structures | Туре | Reset/Set voltage (V) | Endurance cycles | Retention time (s) | PPF index | Ref |
|---|--------------------------|--------------------------|---------------------|-----------------------|-----------------|--------------|
| Ag/PMMA/AgBiI4//ITO | Digital | -0.16/+0.16 V | 700 | 104 | | 1 |
| Al/CsBi ₃ I ₁₀ /ITO | Digital | -1.7/+0.9 V | 150 | 104 | | 2 |
| Ag/PMMA/Cs3Cu2I5/ITO | Digital | -0.44/+0.60 V | 100 | 104 | | 3 |
| Ag/CsSnCl ₃ /ITO | Digital and Analog | -1.07/+0.95 V | 105 | 10 ⁴ | 12%*, Δt=10 μs | 4 |
| Ag/PMMA/Cs2AgBiBr6/ITO | Digital and Analog | -0.5/+0.5 V | 110 | 10 ³ | 30%, Δt=0.2 ms | 5 |
| Au/CsCu ₂ I ₃ /ITO | Analog | +0.2/-1.2 V | | | 52%*, Δt=10 ms | 6 |
| Ag/PMMA&Cs2AgSbBr6- NPs/ITO | Digital and Analog | -0.42/+0.67 V | 900 | 10 ⁴ | 25.7%, Δt=10 μs | This work |

Table S1. Comparison of the Ag/PMMA&Cs₂AgSbBr₆-NPs/ITO memristor with previously reported memristors. (* indicates that the data is read from the graph)

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